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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
OSAWA, Atsushi

New York, New York
Date: August 25, 2005

Serial No.: 10/785,685

Group Art Unit: 1761

Date Filed: February 23, 2004

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

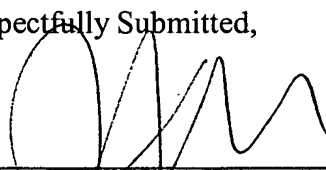
STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on February 23, 2004.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,



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